## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

STAUF, Gregory T., et al.

Application No.:

09/681,609

Date Filed:

Applicant:

May 8, 2001

Title:

BARRIER STRUCTURES FOR INTEGRATION OF HIGH K

OXIDES WITH Cu AND AI

**ELECTRODES** 

Docket No.:

2771-497 (7486)

Examiner:

Thao X. LE

Art Group:

2814

Confirm. No.:

8601

Customer Number 25559

## **FACSIMILE TRANSMISSION CERTIFICATE**

I hereby certify that I am filing this document in the U.S. Patent and Trademark Office on the date specified, as addressed to Mail Stop AF, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, and transmitted via telefaesimile to USPTO Technology Center 2800 telefacsimile number (703) 872-9319.

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Date of Facsimile Transmission: August 19, 2003

## RESPONSE TO MAY 19, 2003 OFFICE ACTION IN UNITED STATES PATENT **APPLICATION NO. 09/681,609**

Mail Stop AF Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

This responds to the May 19, 2003 Office Action in the above-identified application.

Please amend the claims as set out in Section I (Amended Claims) beginning on the following page.

Remarks relating to the patentability of the amended claims are set out in Section II (Remarks) hereof.